



Docket No.: P2001,0134

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By: 

Date: May 25, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No.	:	10/649,411	Confirmation No.:	5308
Applicant	:	Heike Drummer, et al.		
Filed	:	August 27, 2003		
Title	:	Process for Producing and Removing a Mask Layer		
Art Unit	:	1765.0		
Examiner	:	Kin Chan Chen		
Docket No.	:	P2001,0134		
Customer No.	:	24131		

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. 1.97(C)(2)

Hon. Commissioner for Patents
Alexandria, VA 22313-1450

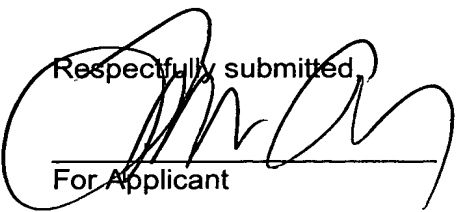
Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are cited herewith:

Japanese Patent No. JP 07-86393 A (Kiyotoshi, et al.), dated March 31, 1995, and English abstract thereof;

Japanese Office Action, dated April 25, 2006.

Respectfully submitted,


For Applicant

Date: May 25, 2006

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FORM PTO-1449 (SUBSTITUTE) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))	Attorney Docket No.: P2001,0134	Applic. No. 10/649,411
	Applicant Heike Drummer, et al.	
	Filing Date August 27, 2003	Group Art Unit 1765.0

U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A						
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						

FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO
	J	JP 07-86393	3/1995	Japan			
	K						
	L						
	M						
	N						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	O	
	P	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.